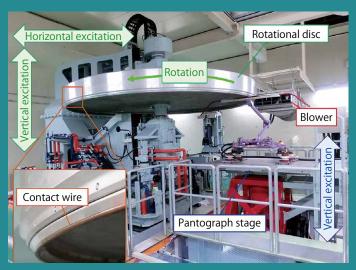
High-Speed Test Facility for Pantograph / OCL Systems



Appearance of HiPaC

Performance of HiPaC

Device	Specification		
Main Machine	Rotational speed	Max. 500 km/h	
	Vertical vibration	Frequency	≤ 27.8 Hz
		Amplitude	Max. 100 mm*1
		Waveform	Sine wave or other*2
	Horizontal vibration	Frequency	≤ 5 Hz
		Amplitude	Max. 300 mm*1
		Waveform	Triangular wave, sine wave, or other*2
Pantograph stage	Elevating amount	1600 mm	
	Vertical vibration	Frequency	≤ 10 Hz
		Amplitude	35mm* ¹
		Waveform	Sine wave or other*2
Environmental atmosphere controller	Temperature	-20 to +40 °C*3	
	Humidity	10 % to 90 %	
Blower	Wind speed	60 to 100 km/h	
Energizing device	Туре	AC or DC	
	Voltage	100 to 600 V	
	Current	≤ 1000 A (10-step control)	

- Depends on the frequency
- Can be vibrated with any waveform by inputting an external signal. When the main machine is active (controllable at -25 to +40 $^{\circ}$ C at a atandstill)

RTRI has developed a new test facility "High-Speed Test Facility for Pantograph/OCL (Overhead Contact Line) Systems (HiPaC)" at our Kunitachi laboratory, in order to carry out the following research and development:

- Evaluate current collection performance of pantographs,
- Evaluate current collection performance of pantographs,
- Develop pantographs for high-speed trains with lownoise and large current collection performance,
- Develop contact strips with improved wear resistance,
- Analyze causes of failure by reproducing power supply and environmental conditions, sliding, and vertical and lateral displacement of the contact wire.

To achieve these, HiPaC can carry a large current (up to 1,000 A) while reproducing high-speed sliding (up to 500 km/h). Appearance of HiPaC shows the appearance of HiPaC, which is composed of the following main

- Main machine: a rotating disk that reproduces the OCL lateral position, vertical vibration, and sliding.
- Pantograph stage: allowing an actual pantograph to be installed and reproducing the vertical vibration of
- Energizing device: supplying electricity to the pantograph.
- Environmental atmosphere controller: controlling the temperature and humidity in the test chamber.
- Blower: reproducing the cooling of the pantographhead due to the oncoming wind during running.

Performance of HiPaC summarizes HiPaC's performance. We intend to use HiPaC to develop a new pantograph with high performance.

> (Tatsuya Koyama, Senior Researcher, Current Collection)

No. 9 October 2021 Ascent 21